

**Amendments To The Specification**

Please amend the specification as follows:

[0021] Fig. 1 is a simplified representation of a workstation including a processing chamber in accordance with an embodiment of the invention with an internal handling system. The workstation has a loading station in the front of the processing chamber for receiving a wafer cassette. The processing chamber has a cooling plate and a heating plate one in front of the other. Fig. 1 shows that the cooling plate, heating plate and the loading station for receiving a wafer cassette may be disposed one in front of the other in a row (e.g., parallel to the rails of the internal handling system); and